



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masateru YAMAMOTO et al.

Group Art Unit: 2828

Application No.: 10/625,687

Examiner: T. NGUYEN

Filed: July 24, 2003

Docket No.: 116661

For: SURFACE EMITTING SEMICONDUCTOR LASER AND METHOD OF
FABRICATING THE SAME

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 16, 2005 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.